(Rev. 8-83)  U.S. Departs of Commerce Patent and Trademark Office				Attorney Docket No. 0756-		Serial No. 08(8) 8,884	
INFORMATION DISCLOSURE STATEMENT						PEC 2 0 2000 9	
(Use several sheets if necessary)				Applicant: Shunpei YAMAZAKI et al.			
				Filing Date: March 17, 1997		Group: 2871	
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"The Physics of Hydrogenated Amorphous Silicon I Structure, Preparation, and Devices@, Edited by J.D.  Joannopoulus and G. Lucovsky, Springer Vorlag, Berlin Heidelberg, New York, Tokyo 1984, pp. 8-9-&-38-41.  (sorrection)							
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